Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/644,794	NOJIRI ET AL.
Examiner	Art Unit
Emily Y. Chan	2829

SEARCHED					
Class	Subclass	Date	Examiner		
324	770	5/9/2005	EC		
324	750-765	5/9/2005	EC		
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INTERFERENCE SEARCHED				
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	DATE	EXMR
Inventorship and EAST for all databases searched.	5/9/2005	EC
Consulted with primary examiner Vinh P Nguyen.	5/9/2005	EC
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